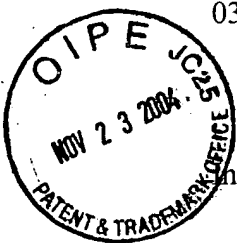


AT/2815/1A
[Signature]

03500.016133

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TADAYOSHI MUTA,

Application No.: 10/052,450

Filed: January 23, 2002

For: SEMICONDUCTOR DEVICE,
PRODUCTION METHOD THEREFOR, AND
ELECTROPHOTOGRAPHIC APPARATUS

)
:
) Examiner: Eugene Lee
:
) Group Art Unit: 2815
:
)
:
)
:
)
:
) November 23, 2004

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the foreign patent documents, together with English-language abstracts, are enclosed.

The listed documents were cited in a Office Action in a corresponding Korean application. A copy of the Office Action, which is dated September 23, 2004, is enclosed.

According to a commercial database, U.S. Patent No. 6,252,777 is in the same family as Korea 2001-0006162.

11/24/2004 LWONDIM1 00000057 10052450

01 FC:1806

180.00 DP

STATEMENT UNDER 37 C.F.R. § 1.97(e)

Each item of information in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing date of this Statement.

FORMAL MATTERS

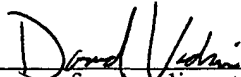
We also enclose a check for \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. § 1.97(d)(2). Any overpayment should be credited and any deficiency should be charged to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant
Damond E. Vadnais
Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200
DEV
DC_MAIN 185508v1

